OIPE IAP58
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PATENT & TRADEMARK OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	
Kenshi KANEGAE et al.	)	Group Art Unit: 1765
Serial No. 10/679,464	)	Examiner: Kin-Chan Chen
Filed: 10/7/2003	)	Confirmation No. 5297
For: ETCHING METHOD, SEMICONDUCTOR AND FABRICATING METHOD FOR THE SAME	))))	Date: July 6, 2006

CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: Mail Stop _____, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, or being facsimile transmitted to the USPTO at 571 273 8300 , on July 6, 2006.

Signature: _____

Name: Jeannie Saxton

AMENDMENT

Mail Stop
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 6, 2006, please amend the above-identified application as follows.